

16987 U.S. PRO  
10/07/593  
02/13/02

**P**  
**U.S. UTILITY Patent Application**

**PATENT NUMBER and  
ISSUE DATE**

APPL NUM 10075193	FILING DATE 02/13/2002	CLASS 438	SUBCLASS 253	GAU 2813	EXAMINER Yonrk HUYNH
----------------------	---------------------------	--------------	-----------------	-------------	-------------------------

\*\*APPLICANTS: Chen Sheilin; Fing Er-Xuan; *yes*

\*\*CONTINUING DATA VERIFIED:  
THIS APPLICATION IS A DIV OF 09/933,913 08/20/2001 *yes*

**BEST AVAILABLE COPY**

*No one*

\*\* FOREIGN APPLICATIONS VERIFIED: *yes*

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	MI22-1927
Verified and Acknowledged Examiners's initials <i>Yonrk</i>			
TITLE : Methods of forming a capacitor structure			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims:	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Fig.s Drawg.
TERMINAL		Print Fig.	
DISCLAIMER		Application Examiner	
PREPARED FOR ISSUE			
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			
FILED WITH: <input type="checkbox"/> DISK (CRF) <input type="checkbox"/> CD-ROM (Attached in pocket on right inside flap)			